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Legal Representative:

Attorney or Agent: Jeffrey L. Costellia

Registration Number: 35483

Customer Number Correspondence Address: 22204

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398, Hase,

Atsugi-shi, 243-0036 Kanagawa-ken JP

INVENTOR(s):

Primary Citizenship: JAPAN

Given Name: Shinji

Family Name: MAEKAWA

Residence City: Atsugi, Kanagawa

Residence Country: JP

Address: c/o Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi, Kanagawa-ken, 243-0036 JP

Primary Citizenship: JAPAN

Given Name: Hidekazu

Family Name: MIYAIRI

Residence City: Tochigi, Tochigi

Residence Country: JP

Address: c/o Semiconductor Energy Laboratory Co., Ltd.
398, Hase,
Atsugi-shi, Kanagawa-ken, 243-0036 JP